

FILTRATION APPLICATION INFORMATION

Type of solution	Operating temperature
Solution used for Cleaning, Cooling, Cool	ting, \square etching, \square rinsing, \square otherition
	%
	%
Materials of construction desired	
	Stampings Profile Circuit board Various
Type of line	
	L x W x H
	Pump Model:
-	_ , or System Model
	ductor
	/es: ☐ Heater ☐ Level Control ☐ pH/ORP ☐ Conductivity
	oor 🚨 None Current micron rating of media
	ng this process solution?
That solicine are expected from properly line	
Degree of clarity desired: Super critical Critic	cal 🖵 Standard 🖵 Minimal Micron rating desired
Does solution require carbon treatment? No	
•	te? Days per week?
☐ Pre-packaged system or ☐ Separate pump ar	• •
If system, where will the system be located? \Box In	
If external, how many feet from process tank?	
If separate: Where will the filter be located? In-tai	
Where will the pump be located? 🚨 In-ta	
Type of filter desired:	
· ·	I Bag ☐ Disc ☐ Mixed media ☐ Gravity
Type of pump desired:	,
	cal seal 🔲 Vertical 🔲 Magnetic coupled 🚨 Air diaphragm
If vertical pump:	
•	Length available Height available
Operating voltage available/_ (volts/phase	
Tank turnovers (per hour) desired 1x 2x 3	•
Please provide sketch of tank accessories connection	